



Form PTO-1449

INFORMATION DISCLOSURE CITATION  
IN AN APPLICATION

(Use several sheets if necessary)

Document Number (Optional)

TSMC-02-1329

Application Number

10/696,642

Applicant

Huan-Liang Tzeng et al.

Filing Date

10/29/03

Group Art Unit

## U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	PUBLICATION DATE IF APPROPRIATE
	6435330	8/20/02	Banora et al.	198	346.3	12/10/99
	6351686	2/26/02	Iwasaki et al.	700	228	7/5/00
	6481558	11/19/02	Banora et al.	198	346.2	12/10/99
	6517304	2/11/03	Matsumoto	414	217	3/28/00
	6315512	11/13/01	Tabrizi et al.	414	217	11/25/98

## FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

## OTHER DOCUMENTS (Including Author, Title, Date, Portion of Pages, Etc.)

10)	-	US Patent App. Publication US 2002/0071744 A1 to Bachrach, Pub date 6/13/02, "Compact Apparatus and Method for Storing and Loading Semiconductor Water Carriers", US Class 414/217, Filed 4/4/02.
10)	-	US Patent App. Publication US 2002/0164242 A1 to Wehrung et al, pub date 11/7/02, "Control System for Transfer and Buffering", US Class 414/935, Filed 1/24/02.

EXAMINER

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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.